DK-US065116

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Junko TAKAHASHI et al.

Patent Art Unit: 1638

Serial No.: 10/581,085

Confirmation No.: 2050

Filed: May 31, 2006

For:

METHOD OF EXAMINING CHEMICAL:

USING GENE-DISRUPTED STRAIN

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner of Patents Washington, DC 20231

Sir:

In accordance with MPEP 609 and 37 C.F.R. §§ 1.56, 1.97 and 1.98, Applicants bring the attached references to the Examiner's attention and request that *they* be considered and made of record in this application. Attached is a completed PTO-1449 form. Also, a copy of Supplementary European Search Report of the corresponding European Application No. 04 81 9823.8 is attached hereto.

No fee is believed to be due for this Information Disclosure Statement. However, if a first Office Action on the merits was mailed before the filing date of this Information Disclosure Statement, the Commissioner is authorized to charge the fee set forth in 37 CFR § 1.17(p) to Deposit Account No. 50-1836.

Prompt examination on the merits is respectfully requested.

Respectfully submitted,

/Patrick A. Hilsmier/ Patrick A. Hilsmier Reg. No. 46,034

GLOBAL IP COUNSELORS, LLP 1233 Twentieth Street, NW, Suite 700 Washington, DC 20036 (202)-293-0444 Dated: April 4, 2008